LEM Field simulations

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GOAL

- LEM electrostatic simulation: identify the most potentially sensitive areas and understand the effect of the different design parameters on the electric field configuration.
- In this first attempt, we have studied the impact on electric field configuration of the variation of the Guard Ring (GR) and the Clearance (CI).
- Next steps: Simulations of the HV connectors and the pillars

SEM Images











Geometric model - Rim



Settings for the simulation

 Anode: V = 0 V
 E. Field ~ 5 kV/cm

 LEM Up: V = -1000 V
 E. Field ~ 30 kV/cm

 LEM Down: V = -4000 V
 E. Field ~ 30 kV/cm

 FR4 - ε = 4.4
 GAr - ε ~ 1

Current LEM design

GR = 2 mm & Cl = 2 mm



GOL-0.002, GI-0.002, Barrace, Elecarcherenthern rowenty, Sensoar, Elecarcipotender (*)

Current LEM design GR = 2 mm & CI = 2 mm

×10³ GR=0.002, CI=0.002 Surface: Electric field norm (kV/cm) Contour: Electric potential (M 50 ₆₀m -0.12 ×10³ -0.37 -0.12 45 1200 -0.61-0.37 1150-0.86 -0.6140 -C X6 -1.11100 1.1-1.35 1050 50 35 -1.35 -1.591000 -1.59 -1.84 1.84 50 30 950 -2.08-2.08900 -2.33 -2.3325 40 -2.57850 -2.57 -2.82-2.02 20 000 -3.06 30 3.06 750 -8.31 -3.31 15 700 -3.55 -3.55 20 -3.0 -3.8 650 10 -1.04 4.04 600 10 4.29 -4.29 -1.53 550 4.53 μm 4.78 1700 1800 1900 2000 2100 2200 2300 2400 2500 2500 -3000 -2000 -1000 1000 2000 3000 4000 #m 0 GR=0.002, CI=0.002, Surface: Electric field norm (KWem), Contour, Electric potential (V) SR=0.002, Cl=0.002_Surface_Electric field norm (kWcm)_Contour: Electric potential (V) Mm. $\times 10^8$ ×10⁸ 1300 -0.12 -0.37 -0.61 -0.86 -11 -0.12 -0.37 -0.61 -0.80 200 1250 45 180 1200 40 -1.1160 1150 -1.35 1.35 35 -1.59 -1.53140 1100 1.84 1.84 30 2.08 -2.08 120 1050 2.33 -2.3325 2.57 100 -2.57 1000 2.82 -2.82 20 80 -3.06 950 -3.06H -3.31 3.31 15 60 900 -0.55 -3.55 -3.8 -3.8 10 40 850 4.04 -4.64 -4.29 4.29 800 204.58 -1.53 -4.78 -4.78750 -400 -300 -200 -100 0 100 200 300 μm

-1500 /^µm 2500 -2400-2300 -2200-2100-2000 -1900-1800-1700-1600

Electric field norm (kV/cm)



Effect of the Clearance



- We compute the field on the surface of the copper plate of the LEM in the two regions drawn above.
- We fix the Guard Ring at 2 mm and compare the field for different values of the Clearance.
- Same behavior in both regions for all values of CI.

Effect of the Guard Ring in Last Hole



- The field in the last hole decreases as we increase the GR for values GR < 1 mm.
- Above 1 mm the field in this region does not change with the GR for Clearance above 2 mm.
- For CI < 2 mm the field shows a slight decrease from GR = 2 mm to GR = 3 mm.

Effect of the Clearance in the Field near Anode Surface



 For clearance up to 3 mm, the maximum field increases when we increase the Clearance. For values above 3 mm the maximum field decreases with Cl, but a constant field of ~10 kV/cm appears in the region between FR4 and anode.



Electric Tield Norm (KV/CM)

with constant electric field.

-4000 x-coordinate (um)

-2000

-10000

-8000

-6000

Conclusions

- The Clearance barely affects the field in the beginning of the Guard Ring or the Last Hole.
- For Clearance above 1 mm, the field in the Last Hole reaches its minimum value with Guard Ring of 1 mm, and stays the same for higher values of GR.
- A guard ring above 1mm guarantees the minimum electric field on the last hole and on the end of the guard ring

BACK UP

Current design - GR = 2 mm & Cl = 2 mm





Field between LEM and Anode



- We compute the electric field norm along a horizontal line between LEM and Anode.
- We both study the effect of the CI with fixed GR (above) and the effect of the GR with fixed CI (below).
- For different values of GR the field exhibits the exact same behavior.
- As we increase the CI, the field between the insulator and the anode is also increased.

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Effect of the Guard Ring in the beginning of the Guard Ring



Electric field norm (kV/cm)